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SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
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RULE						
APPLICANTS Hiroshi Mashima, Nagasaki, JAPAN; Akira Yamada, Nagasaki, JAPAN; Keisuke Kawamura, Nagasaki, JAPAN; Kenji Tagashira, Nagasaki, JAPAN; Yoshiaki Takeuchi, Nagasaki, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/13821 10/29/2003						
** FOREIGN APPLICATIONS ***** JAPAN 2002-317539 10/31/2002						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 2	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 3
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and	/KELLY M STOUFFER/	Initials				
Acknowledged	Examiner's Signature					
ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES						
TITLE Plasma chemical vapor deposition method and plasma chemical vapor deposition device						
FILING FEE RECEIVED 1260	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
			<input type="checkbox"/> 1.16 Fees (Filing)			
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